

2023 Source Workshop

October 21st - 25th, 2023

In-Person Workshop Held in Aachen, Germany

- First Call for Papers -



First Call for Papers

We are excited to announce the first call for papers for the 2023 Source Workshop. This year, the workshop will be held in-person in Aachen, Germany, co-organized with Fraunhofer-ILT and RWTH-Aachen University and EUV - IUCC. Our annual Source Workshop, focus on the latest scientific and technical developments related to extreme ultraviolet (EUV) and soft to hard X-ray sources. The workshop will provide a forum for researchers, suppliers and end-users in the EUV and X-ray light source area to present their work and discuss a wide range of potential applications. The primary focus will be on the generation of photons using laser-produced plasma (LPP), discharge-produced plasma (DPP), high-harmonic generation (HHG), free electron lasers (FEL), synchrotrons and innovative concepts. We also welcome papers describing the application of these sources in EUV lithography for scanners and metrology, microscopy, analytical instrumentation and supporting scientific research in material and biological sciences. In addition to experimental studies, we encourage the submission of theoretical and modeling papers. Additional special topics and a complete list of topics for the workshop will be announced on our website www.euvlitho.com.

Abstracts of 200 words or fewer should be sent to abstracts@euvlitho.com by September 4, 2023. We encourage students to participate in the workshop. Please indicate whether an oral or poster presentation is preferred and include each author's full name, e-mail address, affiliation and mailing address. Please also include a brief biography and photograph of the presenting author, for inclusion in the abstract book. The workshop proceedings will be published online and made publicly available after the workshop. Proceedings of the previous workshop are available online at www.euvlitho.com.

For those interesting in sponsoring the workshop, please contact Phylcia Walker at Phylcia.walker@euvlitho.com. For technical questions, please contact Dr. Vivek Bakshi at vivek.bakshi@euvlitho.com or one of the co-chairs of the workshop.

Abstract Due Date:
September 4th, 2023

Submit abstract to
info@euvlitho.com

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Venue

Aachen, Germany

Registration and Travel Information

Coming soon at
www.euvlitho.com

Organized by



